

*Appendix A*  
*Summary of Experimental Stations*  
*(May 31, 2008)*

Table A.1. Public beamlines.

	Name of Beamline	X-rays at Sample				Areas of Research
		Energy Range	Energy Resolution	Photon Flux	Beam Size	
		[keV]	$\Delta E/E$	[photon/s]	[mm]	
<b>Public Beamlines</b>						
<b>BL01B1</b>	XAFS	3.8 ~ 113	$3 \times 10^{-5} \sim 2 \times 10^{-4}$	$10^9 \sim 10^{11}$	-	<ul style="list-style-type: none"> <li>• XAFS in wide energy region (3.8 to 113 keV)</li> <li>• XAFS of dilute systems and thin films</li> <li>• Time resolved XAFS by quick scan</li> </ul>
<b>BL02B1</b>	Single Crystal Structure Analysis	5 ~ 115	$10^{-4}$	$\sim 10^{10}$	0.3(H) $\times$ 0.3(V)	<ul style="list-style-type: none"> <li>• Single crystal structure analysis in X-ray wide energy range</li> <li>• Precise X-ray diffraction analysis of the lattice or charge modulation originated from the phase transition at low temperatures</li> </ul>
<b>BL02B2</b>	Powder Diffraction	12 ~ 35	$\sim 2 \times 10^{-4}$	$\sim 10^{11}$	3.0(H) $\times$ 0.5(V)	<ul style="list-style-type: none"> <li>• Charge density studies closely related to properties of functional materials</li> <li>• Structural aspects of phase transition</li> <li>• Ab initio structure determination using powder diffraction data</li> <li>• Structural refinements by Rietveld method</li> <li>• Thin-film diffraction</li> <li>• In-situ diffraction experiment under gas adsorption and/or photo irradiation</li> </ul>
<b>BL04B1</b>	High Temperature and High Pressure	20 ~ 150	White radiation	-	0.05(H) $\times$ 0.05(V) ~ 10(H) $\times$ 10(V)	<ul style="list-style-type: none"> <li>• Determination of phase relation</li> <li>• Equation of state of mantle</li> <li>• Viscosity of melts</li> <li>• Kinetics of mineral transformation</li> <li>• Rheology of mantle minerals</li> <li>• Structure of melts and glasses at high pressures</li> </ul>
<b>BL04B2</b>	High Energy X-ray Diffraction	Si (111) : 37.8, 113.3 Si (220) : 61.7	$10^{-3}$	$2.2 \times 10^{10}$ (37.8 keV, Flat) $7.1 \times 10^{11}$ (37.8 keV, Bent) $3.4 \times 10^9$ (61.7 keV, Flat) $9.2 \times 10^{10}$ (61.7 keV, Bent)	0.22(H) (37.8 keV) 0.38(H) (61.7 keV)	<ul style="list-style-type: none"> <li>• Structural analysis of glass, liquid, and amorphous materials</li> <li>• X-ray diffraction under ultra high-pressure</li> <li>• Small angle scattering in supercritical fluid</li> <li>• Precise single crystal structure analysis</li> </ul>
<b>BL08W</b>	High Energy Inelastic Scattering	Si (620) : 174 ~ 270 Si (771) : 270 ~ 300 Si (400) : 100 ~ 120	$\sim 2 \times 10^{-3}$ $< 1 \times 10^{-3}$	$5 \times 10^9$ (300 keV) $1 \times 10^{13}$ (100 keV)	1(H) $\times$ 3(V) 2(H) $\times$ 1(V)	<ul style="list-style-type: none"> <li>• Magnetic Compton scattering</li> <li>• High-resolution Compton scattering</li> <li>• High-energy Bragg scattering</li> <li>• High-energy fluorescent X-ray analysis</li> </ul>
<b>BL09XU</b>	Nuclear Resonant Scattering	6.2 ~ 100	-	$4 \times 10^{13}$ (14.4 keV)	1.3(H) $\times$ 0.85(V)	<ul style="list-style-type: none"> <li>• Lattice dynamics by using nuclear inelastic scattering</li> <li>• Time domain M6ssbauer spectroscopy, especially under the extreme conditions</li> <li>• Coherent X-ray optics using nuclear resonant scattering</li> <li>• Nuclear excitation by electron transition (NEET)</li> <li>• Surface structures and residual strain analysis</li> </ul>

	Name of Beamline	X-rays at Sample				Areas of Research
		Energy Range [keV]	Energy Resolution $\Delta E/E$	Photon Flux [photon/s]	Beam Size [mm]	
<b>BL40XU</b>	High Pressure Research	20 ~ 58	$10^{-4}$	$\sim 1 \times 10^{13}$	0.01 ~ 1 diam.	<ul style="list-style-type: none"> <li>Structure analysis and phase transitions under ultra high pressure (DAC experiment)</li> <li>Earth and planetary science</li> </ul>
<b>BL43XU</b>	Surface and Interface Structures	7 ~ 32	$10^{-4}$	$\sim 10^{13}/\text{mm}^2$ (for 12.4 keV)	H: 0.001-0.5, V: 0.001-0.5	<ul style="list-style-type: none"> <li>Atomic-scale structural analysis of a crystal surface, an ultra-thin film and a nanostructure</li> <li>Surface structural analysis</li> <li>Analysis of nanostructures grown at a vacuum/solid, liquid/solid, and solid/solid interface</li> </ul>
<b>BL44B2</b>	Engineering Science Research II	3.8 ~ 72	$10^{-4}$	$\sim 10^{10}$	-	<ul style="list-style-type: none"> <li>XAFS in wide energy region (3.8 to 72 keV)</li> <li>XAFS of dilute systems and thin films</li> <li>Time resolved XAFS by quick scan</li> </ul>
<b>BL49B2</b>	Engineering Science Research I	5 ~ 72	$10^{-4}$	$10^9$	-	<ul style="list-style-type: none"> <li>Residual stress measurement, and structural analysis of thin film, surface and interface</li> <li>Powder diffraction</li> <li>X-ray imaging</li> <li>Ultra-small angle X-ray scattering</li> </ul>
<b>BL20XU</b>	Medical and Imaging II	Si (111): 7.62 ~ 37.7 Si (511): 23 ~ 113	$\sim 10^{-4}$	$10^{13}/\text{mm}^2$ (@EH1) for Si (111)	1.4(H) $\times$ 0.7(V) (@EH1) 4(H) $\times$ 2(V) (@EH2)	<ul style="list-style-type: none"> <li>Micro-imaging : Hard X-ray microbeam/scanning microscopy, imaging microscopy, micro-tomography, phase-contrast microtomography with Bonse-Hart interferometer, X-ray holography, coherent X-ray optics, and other experiments on X-ray optics and developments of optical elements</li> <li>Medical application : Micro-angiography, refraction-enhanced imaging, radiation therapy, phase-contrast CT using interferometer</li> <li>Ultra-small angle scattering</li> </ul>
<b>BL20B2</b>	Medical and Imaging I	Si (311) : 8.4 ~ 72.5 Si (111) : 5 ~ 37.5 Si (511) : 13.5 ~ 113.3	$\sim 10^{-4}$	-	75(H) $\times$ 5(V) (Si (311), @Exp. Hall) 300(H) $\times$ 20(V) (Si (311), @Biomedical Imaging Center)	<ul style="list-style-type: none"> <li>The medical research mainly involves micro-radiography, micro-tomography and refraction-contrast imaging on biological specimens and small animals.</li> <li>Imaging techniques involve the evaluation and development of various kinds of optical elements for novel imaging techniques.</li> </ul>
<b>BL25SU</b>	Soft X-ray Spectroscopy of Solid	0.22 ~ 2	$E/\Delta E > 10^4$	$> 10^{11}$	$< 0.4$ diam.	<ul style="list-style-type: none"> <li>Observation of electronic structures by photoemission spectroscopy (PES)</li> <li>Observation of electronic band structures by angle resolved photoemission spectroscopy (ARPES)</li> <li>Magnetic state study by magnetic circular dichroism (MCD) of soft-x-ray absorption</li> <li>Element-specific magnetization curve measurements by MCD</li> <li>Analysis of atomic arrangements by photoelectron diffraction (PED)</li> <li>Observation of Magnetic domains by photoelectron emission microscope (PEEM)</li> </ul>

X-rays at Sample						Areas of Research
Name of Beamline	Energy Range [keV]	Energy Resolution $\Delta E/E$	Photon Flux [photon/s]	Beam Size [mm]		
BL27SU	0.2 ~ 2 for A and B branches 0.3 ~ 2.8 at 1 <sup>st</sup> (Horizontal Polarization) 0.17 ~ 2.8 at 0.5 <sup>th</sup> (Vertical Polarization), for C branch	$10^{-2}$ for A- and B branches $< 10^{-4}$ for C branch	$> 10^{15}$ $> 10^{11}$ for $< 1000$ eV	$4(H) \times 2(V)$ $0.2(H) \times 0.2(V)$ for C1 and C2 $0.2(H) \times 0.01(V)$ for C3	<p><i>Industrial research --- B branch</i></p> <ul style="list-style-type: none"> <li>• Growth of thin film of functional material</li> <li>• Micro fabrication by functional material etching</li> </ul> <p><i>Atomic and molecular spectroscopy --- C branch (C1, C2 station)</i></p> <ul style="list-style-type: none"> <li>• Search of novel photochemical processes</li> <li>• High resolution atomic and molecular electron spectroscopy</li> <li>• Complete determination of electronic decay channel</li> <li>• Dissociation dynamics of inner-shell excited molecules</li> <li>• Site-specific dissociation processes of isolated molecules</li> </ul> <p><i>Solid state physics --- C branch (C3 station)</i></p> <ul style="list-style-type: none"> <li>• Study of electronic structures of solids by photoemission spectroscopy and soft X-ray emission spectroscopy</li> </ul>	
BL28B2	$> 5$	White radiation	-	$50(H) \times 10(V)$ at 44 m from the light source	<ul style="list-style-type: none"> <li>• White X-ray diffraction and topography</li> <li>• Time-resolved energy-dispersive XAFS (DXAFS) for studies of chemical and/or physical reaction process.</li> <li>• Biomedical imaging and radiation biology studies.</li> </ul>	
BL35XU	8 ~ 50 (fundamental to 5th)	$10^{-4} - 10^{-8}$	Optics Dependent		<ul style="list-style-type: none"> <li>• Dynamics of materials on meV energy scales: Phonons, Excitations in Liquids and Glasses</li> <li>• Methods of investigation include inelastic X-ray scattering (IXS) and nuclear resonant scattering (NRS).</li> <li>• Focal spot size of <math>\phi 20</math> microns possible with KB setup</li> </ul>	
BL37XU	A branch : 5 ~ 37 B branch : Si (111) : 75.5	Both: $2 \times 10^{-4}$	A branch : $10^{12} \sim 10^{13}$ B branch : $10^{10} \sim 10^{12}$	A branch : $2(H) \times 0.7(V)$ B branch : $3(H) \times 0.5(V)$	<ul style="list-style-type: none"> <li>• X-ray microbeam spectrochemical analysis</li> <li>• Ultra trace element analysis</li> <li>• High energy X-ray fluorescence analysis</li> </ul>	
BL38B1	6.5 ~ 17.5	$\sim 2 \times 10^{-4}$	$10^{10} \sim 10^{11}$	-	<ul style="list-style-type: none"> <li>• Routine data collection for macromolecular crystallography</li> </ul>	
BL39XU	5 ~ 38	$1 \times 10^{-4}$	$2 \times 10^{13}$	$0.6(H) \times 0.6(V)$	<ul style="list-style-type: none"> <li>• X-ray magnetic circular dichroism (MCD) spectroscopy</li> <li>• Element-specific magnetometry</li> <li>• X-ray emission spectroscopy and its magnetic circular dichroism</li> <li>• Resonant or non-resonant magnetic scattering</li> <li>• XMCD microscopy, element-specific magnetometry in a micrometer region</li> <li>• XMCD experiment under high (<math>\sim 10</math> GPa) pressure</li> <li>• X-ray spectroscopy using variable light polarization</li> </ul>	
BL40XU	8 ~ 17	0.02	$10^{15}$ (12 keV)	$0.25(H) \times 0.04(V)$ (with focusing mirrors)	<ul style="list-style-type: none"> <li>• Time-resolved diffraction and scattering experiments</li> <li>• X-ray speckle experiments</li> <li>• Microbeam X-ray diffraction experiments</li> </ul>	
BL40B2	6 ~ 17.5	$10^{-4}$	$\sim 10^{11}$ (12 keV)	$0.25(H) \times 0.2(V)$	<ul style="list-style-type: none"> <li>• Noncrystalline small and wide angle X-ray scattering</li> </ul>	

	Name of Beamline	X-rays at Sample				Areas of Research
		Energy Range	Energy Resolution	Photon Flux	Beam Size	
		[keV]	$\Delta E/E$	[photon/s]	[mm]	
<b>BL41XU</b>	Structural Biology I	6.5 ~ 17.5 19 ~ 37 (optional)	$< 2 \times 10^{-4}$	$> 10^{13}$ (without slits) $> 5 \times 10^{11}$ (with slits)	0.07(H) $\times$ 0.05 (V) 0.025(H) $\times$ 0.025 (V) (minimum size)	<ul style="list-style-type: none"> <li>Structural biology</li> <li>Macromolecular crystallography</li> <li>Ultra-high resolution structure analysis</li> <li>Microcrystallography</li> </ul>
<b>BL43IR</b>	Infrared Materials Science	100 ~ 20000 $\text{cm}^{-1}$	$\sim 0.1 \text{ cm}^{-1}$	-	0.01	<ul style="list-style-type: none"> <li>Infrared microspectroscopy</li> <li>Magneto-optical spectroscopy</li> </ul>
<b>BL46XU</b>	Engineering Science Research III	6 ~ 35	$\sim 10^{-4}$	$\sim 10^{13}$	$< 0.5(\text{H}) \times 0.5(\text{V})$	<ul style="list-style-type: none"> <li>Structural characterization of thin film by X-ray diffraction and X-ray reflectivity measurement</li> <li>Residual stress measurement</li> <li>Time resolved X-ray diffraction</li> <li>Hard X-ray Photoemission Spectroscopy</li> </ul>
<b>BL47XU</b>	HXPES, MCT	5.2 ~ 37.7	$\sim 2 \times 10^{-4}$	$2 \times 10^{13}$ (18 keV)	1.2(H) $\times$ 0.3(V) (18 keV, 40 m from source)	<ul style="list-style-type: none"> <li>Hard X-ray Photoelectron Spectroscopy</li> <li>Projection type micro-tomography</li> <li>Imaging type micro-tomography</li> <li>Hard X-ray microbeam/scanning microscopy</li> </ul>

Table A.2. RIKEN beamlines.

	Name of Beamline	X-rays at Sample				Areas of Research
		Energy Range	Energy Resolution	Photon Flux	Beam Size	
		[keV]	$\Delta E/E$	[photon/s]	[mm]	
<b>RIKEN Beamlines</b>						
<b>BL17SU</b>	RIKEN Coherent Soft X-ray Spectroscopy	0.3~1.8	$E/\Delta E > 10^4$	$> 10^{11}$	$< 0.1(\text{H}) \times 0.1(\text{V})$	<p><i>Spectroscopic study on multiply charged ions --- A1a station</i></p> <ul style="list-style-type: none"> <li>Photoabsorption study on multiply charged ions</li> <li>Fundamental research for X-ray astronomy using synchrotron radiation</li> </ul> <p><i>High resolution photoemission spectroscopy --- A2 station</i></p> <ul style="list-style-type: none"> <li>Angle-resolved photoemission (ARPES) study using soft X-rays to observe 'bulk' band structure</li> </ul> <p><i>In situ ARPES measurement on strongly-correlated transition-metal oxide thin films fabricated by laser MBE method</i></p> <p><i>Soft X-ray emission spectroscopy for solid and biological samples --- A3 station</i></p> <ul style="list-style-type: none"> <li>Study of the electronic structure of liquid and biological samples by soft X-ray emission spectroscopy</li> </ul> <p><i>Soft X-ray diffraction spectroscopy --- B1 station</i></p> <ul style="list-style-type: none"> <li>Soft X-ray diffraction on the ordered materials to study the electronic structure</li> </ul> <p><i>Surface science --- B2 station</i></p> <ul style="list-style-type: none"> <li>Soft X-ray spectroscopy to study the surface adsorbates and interfaces</li> </ul>
<b>BL19LXU</b>	RIKEN SR Physics	7.2 ~ 18 (fundamental) 22 ~ 51 (3rd)	$\sim 10^{-4}$	$2 \times 10^{14}$ (14 keV)	1.5(H) $\times$ 0.8(V) (@EH2)	<ul style="list-style-type: none"> <li>This beamline is open for any research field requiring the highly brilliant X-ray beam</li> </ul>

	Name of Beamline	X-rays at Sample				Areas of Research
		Energy Range	Energy Resolution	Photon Flux	Beam Size	
		[keV]	$\Delta E/E$	[photon/s]	[mm]	
<b>BL26B1&amp;B2</b>	RIKEN Structural Genomics I & II	6 ~ 17	$\sim 10^{-4}$	$\sim 10^{11}$ (12 keV)	-	<ul style="list-style-type: none"> <li>Structural genomics research based on single crystal X-ray diffraction</li> </ul>
<b>BL29XU</b>	RIKEN Coherent X-ray Optics	4.4 ~ 37.8	$\sim 1.3 \times 10^{-4}$	$6 \times 10^{13}$ (10keV)	1.6(H) $\times$ 0.7(V) (@EH1) 2.9(H) $\times$ 1.2(V) (@EH2) 28(H) $\times$ 12(V) (@EH3)	<ul style="list-style-type: none"> <li>X-ray optics, especially coherent X-ray optics</li> </ul>
<b>BL44B2</b>	RIKEN Structural Biology II	6 ~ 18	$\sim 10^{-4}$	$1.1 \times 10^{11}$ (12.4 keV)	0.20(H) $\times$ 0.22(V)	<ul style="list-style-type: none"> <li>Macromolecular crystallography</li> </ul>
<b>BL45XU</b>	RIKEN Structural Biology I	6.8 ~ 14 (@SAXS Station) 7.5 ~ 14 (@SWAXS Station)	$< 10^{-4}$ (@SAXS St.) $< 10^{-4}$ (@SWAXS St.)	$\sim 1 \times 10^{12}$ (@SAXS St.) $\sim 2 \times 10^{11}$ (@SWAXS St.)	0.4(H) $\times$ 0.2(V) (@SAXS St.) 0.3(H) $\times$ 0.2(V) (@SWAXS St.)	<ul style="list-style-type: none"> <li>SAXS-station: Time-resolved structures of non-crystalline biological materials such as protein, nucleic acid solutions, membrane, muscle, and micelle system under various conditions, are studied by using small-angle scattering and diffraction technique.</li> <li>SWAXS-station: Wide-scale structural analysis for nano- and meso-structure in soft-condensed matters such as polymer, lipid and complex fluid systems are investigated by using small- and wide-angle X-ray scattering/diffraction techniques.</li> </ul>

Table A.3. Contract beamlines.

	Name of Beamline	X-rays at Sample				Areas of Research
		Energy Range	Energy Resolution	Photon Flux	Beam Size	
		[keV]	$\Delta E/E$	[photon/s]	[mm]	
<b>Contract Beamlines</b>						
<b>BL08B2</b>	Hyogo BM (Hyogo Prefecture)	4.6~70	$< 10^{-4}$	$\sim 10^4$ - $10^{10}$	-	<ul style="list-style-type: none"> <li>XAFS in a wide energy region</li> <li>Small angle X-ray scattering for structural analyses of polymer and nano-composite materials</li> <li>X-ray topography</li> <li>Imaging</li> <li>Powder diffraction with a high angular resolution</li> </ul>
<b>BL11XU</b>	JAEA Quantum Dynamics (Japan Atomic Energy Agency)	6 ~ 70	$10^{-4}$	-	-	<ul style="list-style-type: none"> <li>Nuclear Resonant Scattering</li> <li>Surface and interface structure with MBE</li> <li>Inelastic scattering</li> <li>XAFS</li> </ul>

	Name of Beamline	X-rays at Sample				Areas of Research
		Energy Range	Energy Resolution	Photon Flux	Beam Size	
		[keV]	$\Delta E/E$	[photon/s]	[mm]	
<b>BL12XU</b>	NSRRC ID (National Synchrotron Radiation Research Center, Taiwan)	4.5 ~ 35	1.4 × 10 <sup>-4</sup> for DCM  10 <sup>-5</sup> ~ 10 <sup>-7</sup> for HRM (optics dependent)	~ 10 <sup>10</sup> photons/s/meV below 26 keV after DCM  Optics dependent at sample	0.12(H) × 0.08(V)	<ul style="list-style-type: none"> <li>Elementary electronic excitations, quasiparticle behaviors, and electron-correlation effects in correlated electron systems investigated using high resolution non-resonant or resonant inelastic X-ray scattering</li> <li>Local electronic structure of molecular solids of low-Z elements (e.g., biomaterials) investigated by high resolution near-edge X-ray Raman scattering</li> <li>Phase transitions under high-pressure, low and high temperatures</li> <li>Materials science using high-resolution X-ray absorption and emission spectroscopy</li> <li>X-ray physics and optics</li> </ul>
<b>BL12B2</b>	NSRRC BM (National Synchrotron Radiation Research Center, Taiwan)	5 ~ 70 (monochromatic)	~ 10 <sup>-4</sup>	10 <sup>10</sup> ~ 10 <sup>12</sup>	0.25(H) × 0.25(V)	<ul style="list-style-type: none"> <li>X-ray absorption spectroscopy</li> <li>Powder X-ray diffraction</li> <li>High resolution X-ray scattering</li> <li>Protein crystallography</li> </ul>
<b>BL14B1</b>	JAEA Materials Science (Japan Atomic Energy Agency)	5 ~ 90 (monochromatic)	SI (111) : 10 <sup>-4</sup> SI (311) : 3 × 10 <sup>-5</sup> SI (511) : 7 × 10 <sup>-6</sup>	10 <sup>10</sup>	3(H) × 1(V) (with bender) 3(H) × 0.2(V) (with bender&mirror)	<ul style="list-style-type: none"> <li>Materials science at high pressure</li> <li>Surface/interface analysis</li> <li>XAFS</li> <li>Pair-distribution function (PDF) analysis</li> </ul>
<b>BL15XU</b>	WEBRAM (National Institute for Materials Science)	1 ~ 60	10 <sup>-4</sup>	10 <sup>12</sup> ~ 10 <sup>13</sup>	0.05(H) × 0.05(V) ~ 3(H) × 3(V)  ~ 0.8 diam.	<ul style="list-style-type: none"> <li>Highly precise characterization of advanced materials</li> <li>High energy excitation X-ray photoelectron spectroscopy</li> <li>Highly precise X-ray powder diffraction</li> </ul>
<b>BL16XU</b>	SUNBEAM ID (Industrial Consortium)	4.5 ~ 40	~ 10 <sup>-4</sup>	~ 10 <sup>12</sup> (normal) ~ 10 <sup>10</sup> (focusing)	< 1(H) × 1(V) ~ 1 μm(H) × 1 μm(V)	<ul style="list-style-type: none"> <li>Characterization of thin films for ULSI, optical and magnetic devices, secondary batteries, fuel cells, catalysts, functional materials, and structural materials.</li> </ul>
<b>BL16B2</b>	SUNBEAM BM (Industrial Consortium)	4.5 ~ 113	~ 10 <sup>-4</sup>	~ 10 <sup>10</sup>	~ 0.1(H) × 0.1(V) (with mirror) ~ 40(H) × 2(V) (without mirror)	<ul style="list-style-type: none"> <li>Characterization of industrial materials, such as metal and oxide films, semiconductor crystals, etc., by XAFS, topography and other methods</li> </ul>
<b>BL22XU</b>	JAEA Quantum Structural Science (Japan Atomic Energy Agency)	3 ~ 37 by DXM2 35 ~ 70 by DXM1	10 <sup>-4</sup>	2 × 10 <sup>13</sup>	2(V) × 3.2(H) (@EH3) 0.4(H) × 0.5(V) (focusing @EH3), at 1.44 keV	<ul style="list-style-type: none"> <li>Materials science at high pressure</li> <li>Resonant X-ray scattering (activity at RI laboratory)</li> <li>Residual Stress Distribution Measurement</li> </ul>
<b>BL23SU</b>	JAEA Actinide Science (Japan Atomic Energy Agency)	0.35 ~ 1.8	< 10 <sup>-4</sup>	10 <sup>11</sup>	< 0.2 diam.	<ul style="list-style-type: none"> <li>Surface chemistry with supersonic molecular beam</li> <li>Biophysical spectroscopy</li> <li>Photoelectron spectroscopy (activity at RI laboratory)</li> <li>Magnetic circular dichroism (activity at RI facility)</li> </ul>

	Name of Beamline	X-rays at Sample					Areas of Research
		Energy Range	Energy Resolution	Photon Flux	Beam Size	[mm]	
		[keV]	$\Delta E/E$	[photon/s]	$\times 1(V)$		
<b>BL24XU</b>	Hyogo ID (Hyogo Prefecture)	4.5 ~ 35	$< 10^{-4}$	$\sim 10^{12}$	$< 1(H) \times 1(V)$	<ul style="list-style-type: none"> <li>• Structure analysis of small bio-crystals for industry</li> <li>• Crystallographic analysis of metallic materials for industry (surface analysis, strain measurements)</li> <li>• x-ray microscopic application for industry (micro- or nano-beam, high-resolution imaging)</li> </ul>	
<b>BL32B2</b>	Pharmaceutical Industry (Pharmaceutical Consortium for Protein Structure Analysis)	7 ~ 17.5	$\sim 10^{-4}$	$\sim 10^{11}$ (12 keV)	$0.2(H) \times 0.2(V)$ (12 keV)	<ul style="list-style-type: none"> <li>• Protein structure analysis for structure-based drug design: It means design and optimization of new leading compounds based on pharmacodynamic action mechanism elucidated at the molecular level which obtained from a detailed interaction analysis of receptor-drug complexes, etc.</li> </ul>	
<b>BL33LEP</b>	Laser-Electron Photon (RCNP, Osaka University)	1.5 ~ 2.4 GeV (355-nm Solid-state laser) 1.5 ~ 3.0 GeV (257-nm Ar laser)	$\sim 5 \times 10^{-3}$	$4 \times 10^6$ $2 \times 10^5$	-	<ul style="list-style-type: none"> <li>• Meson photoproduction from nucleon and nucleus</li> <li>• Photoexcitation of hyperons, nucleon resonances, and other exotic states</li> <li>• Photonuclear reactions</li> <li>• Beam diagnoses</li> <li>• Test and calibration of detectors with GeV photon beam</li> </ul>	
<b>BL44XU</b>	Macromolecular Assemblies (Institute for Protein Research, Osaka University)	7 ~ 17.5	$2 \times 10^{-4}$	$3 \times 10^{11}$	$0.05(H) \times 0.05(V)$	<ul style="list-style-type: none"> <li>• Crystal structure analysis of biological macromolecular assemblies (e.g. membrane protein complexes, protein complexes, protein-nucleic acid complexes, and viruses)</li> </ul>	

Table A.4. Accelerator beamlines.

	Name of Beamline	X-rays at Sample					Areas of Research
		Energy Range	Energy Resolution	Photon Flux	Beam Size	[mm]	
		[keV]	$\Delta E/E$	[photon/s]			
<b>Accelerator Beamlines</b>							
<b>BL05SS</b>	Accelerator Beam Diagnosis	Visible light, White X-ray, Monochromatic X-ray (4~38keV), $\gamma$ -ray (10.2MeV)(planned)	-	-	-	<ul style="list-style-type: none"> <li>• Accelerator science</li> <li>• Accelerator beam diagnostics</li> <li>• R&amp;D of accelerator components</li> <li>• Production of MeV <math>\gamma</math>-ray photons</li> </ul>	
<b>BL38B2</b>	Accelerator Beam Diagnosis	Visible light, White X-ray, Monochromatic X-ray (4~14keV), $\gamma$ -ray (10.2 MeV)	-	-	-	<ul style="list-style-type: none"> <li>• Accelerator science</li> <li>• Accelerator beam diagnostics</li> <li>• R&amp;D of accelerator components</li> <li>• Production of MeV <math>\gamma</math>-ray photons</li> </ul>	